# **APPENDIX A - SPECIFICATIONS**

#### **MEASUREMENTS**

Roughness Ra, Arithmetic Average

Max Ra, Maximum of 19 overlapping sections

Rq, Root-Mean-Square (RMS)

R<sub>p</sub>, Maximum Height R<sub>v</sub>, Maximum Depth

R<sub>t</sub>, Maximum Peak-to-Valley

R<sub>z</sub>, Ten-Point Height R<sub>3z</sub>, Six-Point Height

Waviness Wa, Arithmetic Average

Wq, Root-Mean-Square Wp, Maxixum Height Wv, Maximum Depth

W<sub>t</sub>, Maximum Peak-to-Valley

Topography

TIR Total Indicator Run-out

Height Height between two points (Step Height)

Average Height Average height of all data points between the measurement cursors relative to the leveled baseline (Delta

Average Mode).

 Cut Off Filter
 mm
 inch
 mm
 inch

 .0045
 .0002
 0.45
 .018

.0002 0.45 .018 .008 .0003 8.0 .03 .0006 .014 1.4 .055 .025 .001 2.5 .1 .045 4.5 .002 .18 .08 .003 8.0 .3 .14 .006 14.0 .55 .25 .01 25.0 1.0

## **PROFILING PERFORMANCE**

MetricEnglishScan Length210 mm8.2 in. maximum.

Scan Speed  $1 \mu \text{m/s}$  to 25 mm/s 0.04 mil/s to 1 in./s

Sampling Rate

50, 100, or 200/s nominal

Vertical Range

At 1Å (0.004 µin.) Resolution:

± 6.5 µm

± 0.25 mil maximum.

At 25Å (0.1 µin.) Resolution:

± 150 μm

± 6 mil maximum + 0.8/-11 mil or

+ 20/-280 μm + 280/-20 μm

+ 11/-0.8 mil

Vertical Linearity, entire range

± 0.5%

± 0.5%

Horizontal Resolution

At 1 um/s scan speed

Metric

English

 $0.01 \, \mu m \, (100 \text{Å})$ 

0.4 µin.

Scan Method

Moving stage, stationary stylus

**Stylus Control** 

Programmable Force:

Range

1.0 - 100 mg

Resolution

0.1 mg

Full retract between scans
Programmable descent rate

# REPEATABILITY AND STABILITY

Step Height Repeatability

13 μm (± 6.5 μm) range 300 μm (± 150 μm) range  $0.001~\mu m~(10\mbox{\normalfont\AA})$  maximum standard deviation  $0.005~\mu m~(50\mbox{\normalfont\AA})$  maximum standard deviation Note: The Step Height Repeatability has been verified using step height standards from VLSI Standards with a sequence of fifty 10~s measure-

ments at a single position.

**Base Line Stability** 

Time Distance 0.02 μm (200Å) maximum TIR for a 100-s scan. 0.2 μm (2000Å) maximum TIR on a profile length of

130 µm verified on a 1/20 optical flat.

**Measurement Environment** 

Floor vibration below 0.2 mG

Audio noise below 80 dB

Ambient temperature range 16-26° C Maximum rate of change 2° C/hour

#### MEASUREMENT CONTROL

Manual/Single Scan Mode

Continuous or segmented scan, from recipe.

Keylock with three Modes

Position 1: Run a single recipe or sequence without

modification.

Position 2: Run any recipe or sequence without

modification.

Position 3: Unlocked. All functions available including

interlock setting.

Repeat and Average Mode

Scan repeated up to ten times and averaged.

**Automatic Sequence Mode** 

Up to 100 recipes and locations combined into a se-

quence of recipes (optional).

## SAMPLE HANDLING

Motorized X-Y

Two programmable locations (Standard Config.)

Unlimited programmability (Automatic Config.)

Via trackball or keyboard

Manual Control

Metric

English

Maximum Sample Size

254 x 254 mm

10 x 10 in.

Note: 355 x 355 mm (14 x 14 in.) with side panel

removed

Note: Stylus can access any part of a 210-mm

(8.2-in.) round sample without sample repositioning.

Open Frame Configuration

Without Removable Isolation Hood:

480 x 480 mm

19 x 19 in.

With Removable Isolation Hood:

430 x 430 mm

 $17 \times 17 \text{ in.}$ 

Note: Inside space of hood is 743 mm (29.25 in.) X, 556 mm (23.1 in.) Y. A 480-mm (19-in.) sample has full 210 mm (8.2 in.) of scan or positioning motion in the X direction but only 100 mm (4 in.) in the Y direction.

Note: Stage Table: 243 x 243 mm (9.57 x 9.57 in.) with switchable vacuum to handle wafer sizes of 100 mm (4 in.) to 200 mm (8 in.). Accommodates

Vacuum Hold-Down of Sample

**Custom Fixturing Interface** 

**Standard Precision Locator** 

Tencor P-2 sample locators.

Note: The stylus can access, without sample repositioning, one 210-mm (8.2-in.) diameter area or a 145-mm (5.7-in.) square area. Also, the stylus can access 86% of a 355-mm (14-in.) or 73% of a 430-mm (17-in.) square sample when the sample is moved to each of four or five positions respectively.

Motorized Level and Rotation Option

Standard with either of the rotating stages

(See Appendix F, "Ordering Information.")

Six mounting holes, 8-32 on 3.6-in. diameter B. C.

Maximum Sample Weight	2.2 kg	5 lb
Throat Depth	228 mm	9 in.
Throat Height, incl. Rotary Stage	63.5 mm	2.5 in.
X,Y Maximum Travel	210 mm	8.2 in.
Stylus and Sample Programmed		
Position Repeatability (1 σ)	2 μm	0.08 mil
X,Y Positioning Speed	Variable up to:	
11,1 1 00000000000000000000000000000000	25 mm/s	1 in./s
Manual Stage Rotation	Unlimited rotation. Can be set with six detents (four at $90^{\circ}$ , two at $\pm 45^{\circ}$ )	
Motorized Stage Rotation	•	
Angle Resolution	0.001 degrees	
Position Repeatability (1 σ)	4 μm	0.16 mil
•	(at 4 in. from center)	
Leveling	Electronic leveling of traces is standard.  Automatic mechanical leveling of sample with	

### **DATA STORAGE**

Hard Disk

40 Mbytes. Stores up to 6000 scans at 1000 points

each.

Diskette

1.4 Mbyte, 3.5 in. Data storage limited to approximately 100 recipes and 200 scans at 1000 points each. (300

scans per diskette dedicated to data.)

Storage Requirements

DOS Operating System: approx. 80 Kbytes Tencor P-2 Program: approx. 500 Kbytes

Recipe: approx. 140 bytes Scan Data (incl. graphs):

Approx. 240 bytes + 250 bytes/s of scan time

(e.g., 20 s scan time: 4240 bytes).

## **DATA ANALYSIS**

**Interactive Graph** 

Two cursor read-out. Cursors move independently or

in tandem.

Delta Average Mode

Each cursor is expandable into a region for measure-

ment or leveling.

**Zoom Box Data Expansion** 

Portion of a graph can be magnified.

**Data Catalog** 

Immediate data retrieval and display from catalog.

**Database Manager Option** 

For each recipe in a given sequence: data table with statistics of mean, standard deviation, minimum, maximum, and range for up to 20 surface analysis

parameters.

Recall or purge data saved on disk using up to

seven user-labeled identifiers in addition to recipe and

sequence identifiers, dates.

Data can be formatted for PC-AT compatible pro-

grams.

Metric/English Units

Parameters displayed in preprogrammed metric or

English units; independent selection of horizontal and

vertical parameters.

### **EQUIPMENT SPECIFICATIONS**

Processor 8038620-MHz controller, PC/AT compatible, runs

MS-DOS Operating System, version 3.3.

Screen Displays magnified image of the sample or output

data. Initial data trace or cross-hair identification of stylus location relative to stage can be superimposed

on sample image.

33 cm (13 in.) diagonal

High resolution: 640 x 350 pixels

Color data display, user-selectable colors

Variable image magnification:

150 - 600X standard.

60 - 240X optional, factory only.

Motorized zoom with keyboard control

Filtered illumination of sample (Yellow-red wavelength only)

Console Built-in keyboard and trackball to program and

operate instrument.

Remote Keyboard Removable keyboard enabling use of PC/AT software

(Automatic Configuration only).

Real Time Clock

Battery-backed clock provides date and time of day.

#### PHYSICAL SPECIFICATIONS

Tencor P-2 without Wafer Handler

Dimensions	Metric	English
Width	57 cm	22.5 in.
Height	75 cm	29.3 in.
Depth	78 cm	30.6 in.

**Open Frame Configuration** 

Width (with hood)	75 cm	29.3 in.
(without hood)	57 cm	22.5 in.
Depth	90 cm	35.6 in.

Note: Feet will fit on a 76-cm (30-in.) deep table.

Hood Door Opening	55 cm	21.9 in.
Overall Width (with hood)	75 cm	29.3 in.
(without hood)	57 cm	22.5 in.

Weight		
Instrument	118 kg	260 lb
Shipping Weight	197 kg	435 lb
Open Frame Configuration		
Instrument Weight	127 kg	280 lb
Tencor P-2 with Wafer Handler		
Dimensions	Metric	English
Width	117 cm	46.0 in.
Height	154 cm	61.0 in.
Depth	78 cm	30.6 in.
Weight		
Instrument	231 kg	510 lb
Shipping Weight	354 kg	780 lb
Electrical	90-130 V, 50/60 Hz	
	180-260 V, 50/60 Hz	
	Power requirements: 150 VA	